

EXPEDITED PROCEDURE  
PURSUANT TO 37 C.F.R. § 1.116  
ART UNIT 2815

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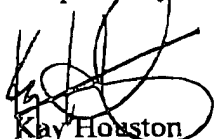
To:	Examiner Edgardo Ortiz	Phone No.	(703) 308-6183
Technology Center:	2815	Total Pages Sent (including cover sheet):	8
Facsimile Number:	(703) 308-7722	Transmission Date:	February 3, 2003
Applicants:	Jingyu Lian, <i>et al.</i>	Docket No.:	00 P 9119 US
Serial No:	09/751,551	Date Filed:	December 28, 2000
Title:	MULTI-LAYER Pt ELECTRODE FOR DRAM AND FRAM WITH HIGH K DIELECTRIC MATERIALS		

## CERTIFICATION OF FACSIMILE TRANSMISSION PURSUANT TO 37 C.F.R. § 1.8(a)(1)(i)(B)

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Amendment Pursuant to 37 C.F.R. § 1.116 (7 pages).

Respectfully submitted,

  
Kay Houston  
Reg. No. 38,495

Confirmation Respectfully Requested

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**EXPEDITED PROCEDURE  
PURSUANT TO 37 C.F.R. § 1.116  
ART UNIT 2815**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Jingyu Lian, *et al.*

Art Unit: 2815

Serial No.: 09/751,551

Examiner: Ortiz, Edgardo

Filing Date: December 28, 2000

Docket No.: 00 P 9119 US

For: **MULTI-LAYER Pt ELECTRODE FOR DRAM AND FRAM  
WITH HIGH K DIELECTRIC MATERIALS**

Commissioner for Patents  
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

**Amendment Pursuant to 37 C.F.R. § 1.116**

Dear Sir:

The following remarks are presented in response to the Examiner's Final Office Action mailed on December 2, 2002. They are respectfully submitted as a full and complete response to that Office Action. Entry of the present amendment and favorable consideration of the above-referenced patent application are respectfully requested.

Please amend the above-referenced application as described below.

In the Claims:

Please amend Claim 29 as follows:

29. (Amended) The multi-layer electrode according to Claim 28 wherein the conductive oxide comprises IrO<sub>2</sub> or RuO<sub>2</sub>.

09/751,551

00 P 9119 US - February 2003 Amendment  
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